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Karen Cinq-Mars 10/6/03
(Signature & date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of _____ : October 6, 2003
Angelopoulos, et al. _____ : Group Art Unit:
Serial No. _____ : Examiner:
Filed: 10/6/2003 _____ : International Business Machines Corporation
2070 Route 52
Hopewell Junction, NY 12533

TITLE: SILICON-CONTAINING COMPOSITIONS FOR SPIN-ON ARC/HARDMASK MATERIALS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the non-US patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,
Angelopoulos, et al.

By Margaret A. Pepper
Margaret A. Pepper
Registration No. 45,008
Telephone No. 845-894-4713

INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Atty. Docket No. FIS920030196US1 (16715)	Serial No. Unassigned
	Applicant Wu-Sung Huang	
	Filing Date Herewith	Group Unassigned

U.S. PATENT DOCUMENTS

EXAMINER'S INITIAL*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)
	6,527,966 B1	03/04/03	Shimomura et al.			
	6,468,718 B1	10/22/02	Kang et al.			
	6,420,088 B1	07/16/02	Angelopoulos et al.			
	6,270,948 B1	08/07/01	Sato et al.			
	6,114,085	09/05/00	Padmanaban et al.			
	6,087,064	07/11/00	Lin et al.			
	6,025,117	02/15/00	Nakano et al.			
	5,641,849	06/24/97	Nishida et al.			
	5,554,485	09/10/96	Dichiara et al.			
	5,380,621	01/10/95	Dichiara et al.			
	4,891,303	01/02/90	Garza et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	1	JP2002164347A	02/20/02	Japan				
	2							
	3							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Y. Matzuura, et al., "Synthesis of Polysilane-Acrylic Copolymers by Photopolymerization and Their Application to Positive Resists for EB Lithography", <u>Journal of Photopolymer Science and Technology</u> , No. 2, 14: 175-180; (2001).

EXAMINER

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